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IN AN APPLICATION**  
(Use several sheets if necessary)

PTO Form 1449

Atty Docket No. 112857-316	Application No. 10/072,223
Applicant Koichi Yoshikawa et al.	
Filing Date 02/06/2002	Group 2872

## **U.S. PATENT DOCUMENTS**

**RECEIVED**

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## **FOREIGN PATENT DOCUMENTS**

Examiner's Initials		OTHER DOCUMENTS ( <i>Including Author, Title, Date, Pertinent Pages, Etc.</i> )

Examiner: Nelson O. Kipf / JP Date Considered: 2/2/2005  
\*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.